

<b>Notice of References Cited</b>	Application/Control No. 10/615,840		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner DAVID Y. CHUNG		Art Unit 2871	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,402,254	03-1995	Sasano et al.	349/38
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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#### FOREIGN PATENT DOCUMENTS

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	N					
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#### NON-PATENT DOCUMENTS

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